



AT
JFW
2824

BOX AF

CERTIFICATION OF MAILING OR FAX TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

By: Hong Hong Chen

Date: April 26, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/631,384 Confirmation No. 9553
Applicant : Werner Plass et al.
Filed : July 31, 2003
TC/A.U. : 2826
Examiner : Ahmed N. Sefer
Title: Surface Emitting Semiconductor Laser Chip and Method for Producing the Chip

Docket No. : P2002,0637
Customer No. : 24131

BOX AF

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE under 37 C.F.R. § 1.116

S i r :

In response to the final Office action dated January 26, 2005 and in consideration of the Advisory action dated April 11, 2005, please consider the following:

Remarks/Arguments begin on page 2 of this paper.

An Appendix including a concise explanation of the relevance of the document "Optoelektronik I," the attorney's letter of May 28, 2002 and the inventor's answer of July 22, 2002 as well as a certified English translation of the priority German application DE 102 34 976.2 is attached following page 10 of this paper.